Docket No: 740756-2683

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of

Setsuo NAKAJIMA

Based On Application No. 10/131,503

) Art Unit: 2814

Which Was Filed: April 25, 2002

For: A METHOD FOR MANUFACTURING A

SEMICONDUCTOR DEVICE

) Date: January 8, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 10/131,503 filed April 25, 2002, from which priority is claimed under 35 U.S.C. 120.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

By:

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Substitute for form 1449A/PTO				Complete if Known		
INFORMATION DISCLOSURE				Application Number	New Application	_
				Filing Date	January 8, 2004	
STATEMENT BY APPLICANT				First Named Inventor	Setsuo NAKAJIMA	
(use as many sheets as necessary)				Art Unit	2814	
				Examiner Name	S. Rao	
Sheet	1	of	1	Attorney Docket Number	740756-2683	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.	U.S. Patent Document Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US-5,352,291	10/04/1994	Zhang et al.		
		US-5,352,291 B1	04/18/2000	Zhang et al.	,	
		US-5,578,520	11/26/1996	Zhang et al.		
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	F	OREIGN PATENT I	DOCUMENTS			
Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶	
	Country Code ³ Number ⁴ Kind Code ³ (if known)					
	JP 07-183540	07/21/1995			Abstract	
	JP 2001-060551	03/06/2001			Full	
	OTHER PRIOR	ART – NON PATENT	LITERATURE DOCUMENTS			
Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.					
	Suga et al. 534-537, 2000 SID 00 DIGEST					
	Specifications and Drawings for Application Serial No. 10/107,592					
	No.¹	Cite No.1 Foreign Patent Document	Cite No.1 Foreign Patent Document Publication Date MM-DD-YYYY	No.1 Name of Patentee or Application of Cited Document Name of Patentee or Application of Cited Document	Cite No. 1 Pages, Columns, Lines, Where Relevant Passages or Relevant	

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.